## Application/Control No. Applicant(s)/Patent Under Reexamination 10/082,228 TATSUURA ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 Edna Wong 1753 **U.S. PATENT DOCUMENTS** Document Number Date Country Code-Number-Kind Code Name MM-YYYY Classification US-4,217,183 Α 08-1980 Melcher et al. 205/92 US-5,296,960 В 03-1994 Ellingson et al. 359/330 С US-D US-US-E US-F US-G US-Н 1 US-US-US-Κ US-L M US-FOREIGN PATENT DOCUMENTS Document Number Date Country Code-Number-Kind Code Country MM-YYYY Name Classification Ν 0 Р Q R S Т **NON-PATENT DOCUMENTS** Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U

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